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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Christoph A. Wasshuber

Art Unit: 2818

Serial No.: 10/714,366

Examiner: Nguyen, T.

Filing Date: 11/13/2003

Docket No.: TI-36280

Customer No.: 23494

Conf. No.: 1864

Title: FORMING A SEMICONDUCTOR STRUCTURE IN MANUFACTURING A SEMICONDUCTOR DEVICE USING ONE OR MORE EPITAXIAL GROWTH PROCESSES

ELECTION

MAILING CERTIFICATE UNDER 37 C.F.R. § 1.8(A)

I hereby certify that the above correspondence is being deposited with the U.S. Postal Service as first Class Mail in an envelope addressed to Commissioner for Patents, PO Box 1450, Alexandria, VA 22313-1450.

12-2-05

Date

Marianna Smith

Marianna Smith

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

With respect to the Restriction Requirement mailed on 11/21/2005, the Examiner has restricted the instant application to the invention of Species I (Claims 1-9, 21-23), or Species II (Claims 10-11), or Species III (Claim 24). In light of this, Applicant elects to pursue Species I, (Claims 1-9, 21-23) without traverse.

Respectfully submitted,


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